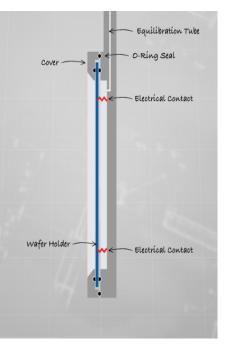


Schematic diagram of the Single EC wafer holder



The Single EC wafer holders are based on the regular Single wafer holders which are in used for more than 15 years in MEMS industry and research. Wafer holders are available for wafers with 3", 4", 5", 6", and 8" diameters. The Single EC series wafer holder protects the wafer's back side and the edge from the etchant solution while allowing to electrically contact the wafers back-side. Should etching capabilities for more than one wafer be required, AMMT offers the Tandem series of holders, which holds two wafers back to back.

All holders are made entirely from PEEK, they are suitable for nearly all etchants (KOH, TMAH, HF, H3PO4, etc.) over an extended temperature range. The wafer is sealed by a double precision O-ring system that reduces mechanical stress on the wafer to a minimum. The cover-ring on the front side holds the wafers in place, fixed by six screws. Since the customer-specific wafer thickness is manufactured as a recess into the cover-ring, all screws can be tightened using a regular wrench, regardless of the applied torque. This ensures a minimum mechanical stress on the fragile wafer.

Upon ordering the holder, the wafer thickness machined as a recess into the cover-ring needs to be specified.

The holder tolerates wafers with a thickness of \pm 80 μ m around the specified target thickness. If more flexibility is required, additionally cover-rings with different recesses can always be ordered.

Furthermore, the volume between the wafer and holder body is connected by a venting tube to the ambient atmosphere in order to avoid pressure caused by temperature changes.

The regular Single EC series is designed for single-side etching processes that do require electrical contacts to the wafers back-side, e. g. electrochemical etch-stop processes or porous silicon formation. Therefore it is equipped with two gold-plated, spring mounted electrical contacts that are placed according to user requirements. In order to keep maintenance costs low, all 0-rings have dimensions in accordance with the American AS-568 standards.

TECHNICAL SPECIFICATIONS

Product code	Single3 EC	Single4 EC	Single4 EC- LAA	Single5 EC			
Wafer size	3" or 75 mm	4" or 100 mm	4" or 100 mm	5" or 125 mm			
Internal dimensions							
Width of the O-ring seal	1.8 mm	1.8 mm	1.8 mm	1.8 mm			
Recommended edge exclusion width	7 mm	7 mm	3.75 mm	7 mm			
Diameter of usable area	61 mm	86 mm	92.5 mm	105 mm			
External dimensions							
Diameter	114 mm	140 mm	140 mm	158 mm			
Thickness	26 mm	27 mm	27 mm	27 mm			
Electrical contacts							
Spring loaded pins (gold-plated)	2 contacts (more up request)						
Etchant compatibility	KOH, TMAH, HF and various acids						
Temperature range	5° C - 150 °C						



We want to ensure that we have close contact with our customers. If you have any questions or special requirements, please do not hesitate to get in touch with us. This product information sheet is for general information purposes only. The product descriptions and the content of this document are not a substitute for our instructions in the product manual.

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Product code	Single 6 EC	Single 6 EC LAA	Single 8 EC		
Wafer size	6" or 150 mm	6" or 150 mm	8" or 200 mm		
Internal dimensions					
Width of the O-ring seal	1.8 mm	2.62 mm	2.62 mm		
Recommended edge exclusion width	7 mm	5.5 mm	5.5 mm		
Diameter of usable area	130 mm	140.5 mm	189 mm		
External dimensions					
Diameter	186 mm	185 mm	240 mm		
Thickness	28 mm	28 mm	30 mm		
Electrical contacts					
Spring loaded pins (gold-plated)	2 contacts (more up request) Contact positions customer specific				
Etchant compatibility	KOH, TMAH, HF and various acids				
Temperature range	5° C - 150 °C				

NOTE AMMT manufactures wafer holders for all sizes of wafers. Holders for single chips and rectangu substrates are available as well. Please inquire for specifications and prices.

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